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Notice of Allowability	Application No.	Applicant(s)
	10/662,382	KANAI ET AL.
	Examiner	Art Unit
	Chris C. Chu	2815
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to <u>11/22/06</u> .		
2. X The allowed claim(s) is/are <u>1 - 8</u> .		
<ul> <li>3. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some* c) None of the:</li> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No.</li> <li>3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
5. CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.		
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached		
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date		
ldentifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
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Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5.  Notice of Informal F	Patent Application
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary	••
3. ☐ Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Da 7. Examiner's Amend	te
Paper No./Mail Date  4.  Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ☑ Examiner's Statem	ent of Reasons for Allowance

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## **DETAILED ACTION**

## REASONS FOR ALLOWANCE

- 1. Claims 1 8 are allowed.
- 2. The following is an examiner's statement of reasons for allowance:

The prior art of record does not teach or suggest, either singularly or in combination, at least peripheral electrodes formed on an outermost portion of a semiconductor chip, internal electrodes, circuits, the peripheral electrodes and the internal electrodes being formed within openings provided in the insulating layer, and wherein rewiring is connected exclusively to either the peripheral electrodes which are not connected to the internal electrodes by the internal lines, or to the internal electrodes which are connected to the peripheral electrodes by the internal lines, and a wire is connected only to the peripheral electrodes connecting to external terminals using wire bonding. Seshan (U. S. Pat. No. 6,686,659) teaches peripheral electrodes formed on a semiconductor chip, internal electrodes, circuits, the peripheral electrodes and the internal electrodes being formed within openings provided in the insulating layer. However, Seshan does not disclose the peripheral electrodes formed on an outermost portion of a semiconductor chip and a wire is connected only to the peripheral electrodes connecting to external terminals using wire bonding, and wherein rewiring is connected exclusively to either the peripheral electrodes which are not connected to the internal electrodes by the internal lines, or to the internal electrodes which are connected to the peripheral electrodes by the internal lines as set forth in claims 1, 5 and 6.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Chris C. Chu whose telephone number is 571-272-1724. The examiner can normally be reached on 11:30 - 8:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kenneth Parker can be reached on 571-272-2298. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Chris C. Chu Examiner . Art Unit 2815

c.c. Monday, December 04, 2006

KENNETH PARKER SUPERVISORY PATENT EXAMINEH